



Applicants: Pil-Kwon Jun

Examiner: Novosad, Jennifer Eleanore

Serial No.: 10/619,999

Group Art Unit: 3634

Filed: July 14, 2003

Docket: 8836-186 (IC12074 US)

For: **WAFER GUIDES FOR PROCESSING SEMICONDUCTOR SUBSTRATES**

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria VA 22313-1450

AMENDMENT TRANSMITTAL FORM

Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ Small entity status of this application under 37 C.F.R. § 1.9 and 1.27 has been established by a verified statement previously submitted.
- ☐ A verified statement to establish small entity under 37 C.F.R. § 1.9 and 1.27 is enclosed.
- ☒ No additional fee is required.

The fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	(Col. 3)	SMALL ENTITY	OTHER THAN SMALL ENTITY
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE
TOTAL	5 *	MINUS 35**	= 0 X	25	\$ 0
INDEP.	1 *	MINUS 7***	= 0 X	100	\$ 0
[] FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				X 180	\$ 360
TOTAL					OR TOTAL \$ 0

ADDIT. FEE \$ 0

*If the entry in Co. 1 is less than entry in Col. 2, write "0" in Col. 3.

**If the "Highest No. Previously Paid for" IN THIS SPACE is less than 20, enter "20".

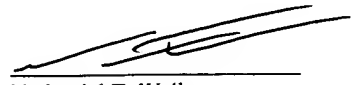
***If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The Highest No. Previously Paid For" (Total or indep.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

- ☐ Please charge Deposit Account No. _____ in the amount of \$ _____. Two (2) copies of this sheet are enclosed.
- ☐ Please charge fee of \$ ____ for _____ by Credit Card Payment Form PTO-2038 enclosed herewith
- ☒ Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. § 1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. **50-0679**. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. **50-0679** therefor. **TWO (2) COPIES OF THIS SHEET ARE ENCLOSED.**

Respectfully submitted,

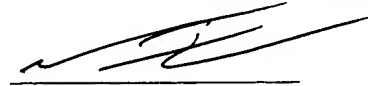
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Nathaniel T. Wallace
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Attorney for Applicant

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 on **April 19, 2005.**

Dated: April 19, 05


Nathaniel T. Wallace

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Jun et al. DOCKET: 8836-186 (IC12074-US)
SERIAL NO: 10/619,999 GROUP ART UNIT: 3634
FILED: July 14, 2003 EXAMINER: Novosad, Jennifer E.
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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 35 U.S.C. 1.111

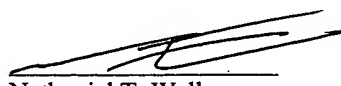
Examiner:

This is in response to the Office Action dated January 25, 2005. Please consider the following amendments and remarks.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

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